

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Confirmation No. 1632

RECEIVED

Norio KIMURA et al.

Docket No. 2001-0660A

OCT 0 8 2003

Serial No. 09/864,208

Group Art Unit 1763

TC 1700

Filed May 25, 2001

Examiner Sylvia MacArthur

SUBSTRATE POLISHING APPARATUS AND SUBSTRATE POLISHING METHOD

PETITION FOR EXTENSION OF TIME

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Petition hereby is made for a one month extension of time to respond to the communication of June 26, 2003.

The fee of \$110.00 is

- (X) submitted herewith.
- to be charged to Deposit Account No. 23-0975. A duplicate copy of this Petition is () enclosed.
- Small entity status of this application is established by a Small Entity Status Assertion () which
 - 0 is enclosed.
 - 0 has been previously submitted.

Respectfully submitted,

THE COMMISSIONER IS AUTHORIZED TO CHARGE ANY DEFICIENCY IN THE FEES FOR THIS PAPER TO DEPOSIT **ACCOUNT NO. 23-0975**

Nils E. Pedersen Registration No.33,145

Attorney for Applicants

NEP/krg

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